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Variations in Discharge Characteristics of Bipolar Pulsed Cold Atmospheric Plasma Jets Induced by Liquid Conductivity

Trial of elemental gradient functional thin films preparation by sputtering with mixed powder targets III

Kyushu University's Latest Initiatives in EUV Light Source Development for Semiconductor Technology

Numerical Simulation of Methylene Blue Decomposition using a Microplasma Contactor

Effect of substrate on growth of nitrogen doped diamond film with plasma enhanced chemical vapor deposition

Effects of Precursor Gas Molecules on the Deposition Properties of Hydrogenated Amorphous Carbon Films by Plasma Chemical Vapor Deposition

Effects on Film Properties Caused by He addition to Ar/C2H2 PECVD

dV/dt Dependence of Characteristics of Surface-Launched Plasma Bullet - A Study up to 356 kV/us using SiC MOS FETs-

Suppression of Compressive Stress in Hydrogenated Amorphous Carbon Films Using Carbon Nanoparticle-Embedded Sandwich Structures

Analysis of hydrocarbon dissociation processes in CXHY+Ar plasma by quadrupole mass spectrometry Enhancement of radical uniformity in CCP using a Rogowski electrode and spatial analysis via OES

High-value conversion of waste oil to hydrogen and C2 gases using pulsed discharge plasma

Plasma streamer propagation dynamics in gas phase DBD, catalyst pores and SDBD

Properties of plasma activated liquids created by using different atmospheric pressure plasma sources

Plasma Interactions at the Interface with Liquids, Nanoparticles and Catalytic Surfaces

Surface reactions of reactive species in low temperature plasma

Advanced Wastewater Treatment Using Underwater Plasma: Insights into Plasma Dynamics and Dye Degradation Efficiency

Atmospheric Pressure Air Plasma for Efficient Degradation of Aging-related Body Odors

Highly-Controlled Thermofluid Fields in Tandem Modulated Induction Thermal Plasmas for High-Rate Nanoparticle Synthesis

Plasma-Assisted Surface Modification of Energy Storage Materials

Multi-scales Modification of Energy Materials by Nonthermal Plasma

Nanostructured Carbon Technologies via Cold/Hot Plasmas for Energy and Media Applications

Innovative Thermal Plasma Generation and Its System for Materials Processing

Modeling and Simulation of Plasma-Assisted Graphene Field Effect Transistor for Biosensing Applications

On the role of sheath layer in nonthermal plasma catalysis

Impact of alloving and exposure temperature on He retention and He thermal dynamics in W-based materials

Mechanism of droplet ejection from liquid metals interacting with hydrogen plasmas

Gas-Liquid Transition and Influence of Density Fluctuations in Supercritical Fluid Plasmas

Low temperature deposition of metal oxide semiconductor material by high-power impulse magnetron sputtering

Study on plasma instabilities in Hall thrusters: mechanisms and mitigation strategies

Ehrenfest Molecular Dynamics for Quantum Process under Ion Injection onto Solid Surfaces and Seed Coats